



MAIL STOP AMENDMENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: F.M. Schellenberg et al. Attorney Docket No.: MEGC122529

Application No.: 10/811,418 Art Unit: 2825 / Confirmation No.: 2647

Filed: March 26, 2004 Examiner: Binh C. Tat

Title: CREATING PHOTOLITHOGRAPHIC MASKS

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Seattle, Washington 98101

February 15, 2006

TO THE COMMISSIONER FOR PATENTS:

Applicants are aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

1. Pursuant to 37 C.F.R. § 1.97(c), this Supplemental Information Disclosure Statement is being filed after the period set forth in 37 C.F.R. § 1.97(b) but before the mailing date of a final action under 37 C.F.R. § 1.113, a Notice of Allowance under 37 C.F.R. § 1.311, or an action that otherwise closes prosecution, and is accompanied by:
 - a. the submission fee set forth in 37 C.F.R. § 1.17(p). Check No. 168679 in the amount of \$180 is enclosed.

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2. X The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 03-1740. A copy of this document is enclosed.

Respectfully submitted,

CHRISTENSEN O'CONNOR
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Rodney C. Tullett
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I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first class mail with postage thereon fully prepaid and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the below date.

Date: February 15, 2006
RCT:jh



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**SUPPLEMENTAL INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL
TO THE PROSECUTION OF THE SUBJECT APPLICATION**

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U.S. PATENT DOCUMENTS

*Examiner	Cite	Kind	Date	
Initials	No.	Document No.	Code	(mm/dd/yyyy)
	U16	6,416,907	B1	07/09/2002
	U17	6,620,561	B2	09/16/2003

FOREIGN PATENT DOCUMENTS

*Examiner	Cite	Kind	Publication Date	Country	English	Abstract	Translation
Initial	No.	Document No.	Code	(mm/dd/yyyy)	Provided	Provided	Provided

None

OTHER INFORMATION
(Including Author, Title, Date, Pertinent Pages, Etc.)

*Examiner	Cite
Initial	No.

None

Examiner **Date Considered**

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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